



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TECHCENTER 2800

Applicant(s): Wayne G. Renken
Title: Process Condition Sensing Wafer and Data Analysis System
Application No.: 10/056,906 Filing Date: January 24, 2002
Examiner: Charles D. Garber Group Art Unit: 2856
Docket No.: SENS.005US0 Conf. No.: 2359

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicant(s) respectfully petition(s) for a three-month extension of time within which to respond to the outstanding Office Action mailed January 12, 2004, such extension allowing the undersigned until July 12, 2004 to respond.

A check is enclosed that includes the amount of \$475.00, as set forth in the enclosed transmittal letter.

EXPRESS MAIL NO.:

EV437667836US

Respectfully submitted,

Peter A. Gallagher
Peter A. Gallagher
Reg. No.47,584

7/12/04
Date

07/15/2004 SSESHE1 00000034 10056906

01 FC:2801
02 FC:2253

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475.00 0P